



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Kazuhiko ENDO

Confirmation No. 6839

Serial No. 10/017,396

GROUP 2813

Filed December 18, 2001

Examiner Yennhu B. HUYNH

SILICA INSULATION FILM WITH A REDUCED DIELECTRIC CONSTANT AND METHOD OF FORMING THE SAME

STATUS INQUIRY

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Please inform us of the status of the above-identified application. The application was filed on December 18, 2001 and was docketed on December 10, 2003 to the Examiner. Applicant respectfully inquires as to when a first Official Action may be expected in this application.

Thank you for your attention to this matter.

Respectfully submitted,

YOUNG & THOMPSON

Robert J. Patch, #17,355

Attorney for Applicant 745 South 23rd Street, Suite 200

Arlington, Virginia 22202 Telephone: (703) 521-2297

RJP/psf January 5, 2004